



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 5212

<b>SERIAL NUMBER</b> 10/520,982	<b>FILING OR 371(c) DATE</b> 03/14/2005 <b>RULE</b>	<b>CLASS</b> 250	<b>GROUP ART UNIT</b> 2881	<b>ATTORNEY DOCKET NO.</b> S004-5433(PCT)
------------------------------------	---	---------------------	-------------------------------	--

## APPLICANTS

Toshio Kodama, Chiba-shi, JAPAN;  
Masakatsu Hasuda, Chiba-shi, JAPAN;  
Toshiaki Fujii, Chiba-shi, JAPAN;  
Kouji Iwasaki, Chiba-shi, JAPAN;  
Yasuhiko Sugiyama, Chiba-shi, JAPAN;  
Yasuyuki Takagi, Chiba-shi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/08691 07/09/2003 *JP*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-204028 07/12/2002 *JP*

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 20	<b>INDEPENDENT CLAIMS</b> 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Jack Bernier</i> Examiner's Signature <i>JP</i> Initials				

## ADDRESS

40627

## TITLE

Ion beam device and ion beam processing method, and holder member

<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
------------------------------------	---	---